## WHAT IS CLAIMED IS:

1 1.	An EM	shielding	structure,	comprising
1 I.	AU FM#	sureraring	Structure,	COMPLIE

a printed circuit having at least one contact 2 protuberance; and

an EMI\ shield member formed with an aperture receiving the contact protuberance,

the EMI shield member having a contact wall defining the aperture, the aperture defining contact wall being in contact with the contact protuberance received in the aperture.

The EMI shielding structure as claimed in claim 1, 2. 1

wherein the contact protuberance has spherical side

surface.

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An EMI shielding structure, comprising: 3.

a printed circuit having at least one contact protuberance, and

an EMI \shield member formed with an aperture receiving the contact protuberance,

the EMI shield member having a contact wall defining the aperture, the aperture defining contact wall being in contact with the contact protuberance received in the aperture,

the contact\protuberance having a vertex protruded 10 through the aperture beyond the EMI shield member. 11

- The EMI shielding structure as claimed in claim 3, 1 4.
- wherein the contact protuberance has cross sections
- gradually reducing in area toward the vertex. 3
- The EMI shielding structure as claimed in claim 3, 1 5.
- wherein the contact protuberance is a circular cone. 2

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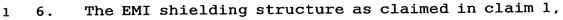
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- 2 wherein the contact protuberance is in biased contact
- 3 with the EMI shield member.
- 1 7. The EMI shielding structure as claimed in claim 6,
- 2 wherein the contact protuberance is formed from a strip
- 3 of springy metal sheet.
- 1 8. The EMI shielding structure as claimed in claim 7,
- 2 wherein the contact protuberance can be resiliently
- 3 deformed between the printed circuit and the EMI shield
- 4 member.
- 1 9. The EMI shielding structure as claimed in claim 7,
- 2 wherein the contact protuberance includes a
- 3 pantograph-like structure.
- 1 10. An EMI shielding structure, comprising:
  - a printed circuit having at least one contact protuberance; and

an EM shield member formed with an aperture receiving the contact protuberance,

the EMI shield member having a contact wall defining the aperture the aperture defining contact wall being in contact with the contact protuberance received in the aperture,

the contact protuberance having a uniform cross sectional area and being fitted into the aperture.

- 1 11. The EMI shielding structure as claimed in claim 10,
- 2 wherein the contact protuberance has a top, which is
- 3 elevated from the printed circuit not further than the
- 4 remote surface of the EMI shield member is elevated from
- 5 the printed circuit.

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12.	An	ЕМІ	shielding	structure,	comprising:
				,	

a printed circuit having at least one contact protuberance; and

an EMI shield member formed with an aperture receiving the contact protuberance,

the EMI shield member having a contact wall defining the aperture, the aperture defining contact wall being in contact with the contact protuberance received in the aperture,

the contact protuberance having a first portion and an integral second portion fitted into the aperture,

the second portion having a cross sectional area less than a cross sectional area of the first portion,

the first portion allowing the EMI shield member to rest thereon.

- 1 13. The EMI shielding structure as claimed in claim 12,
- wherein the second portion has a top, which is elevated
- 3 from the printed circuit not further than the remote
- 4 surface of the EMI shield member is elevated from the
- 5 printed circuit.
- 1 14. A liquid crystal display including an EMI shielding
- 2 structure as claimed in claim 1.
- 1 15. A method of assembling an EMI shielding structure,
- comprising:

forming a printed circuit with at least one contact protuberance;

forming an EMI shield member with an aperture and a contact wall defining the aperture; and

placing the EMI shield member in a desired alignment over the printed circuit in a manner that the aperture receives the contact protuberance in contact with the

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- defining contact wall. 10
- The method as claimed in claim 15, wherein the 16. 1
- contact protuberance protrudes through the aperture 2
- beyond the EMI shield member.
- The method as claimed in claim 15, wherein the 1 17.
- contact protuberance is fitted into the aperture. 2
- An EMI shielding structure, comprising:
  - a ground plane:
  - at least one contact protuberance on the ground
- plane; and 4

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- an EMI shield member formed with an aperture
- receiving the contact protuberance, 6
- the  $\mathtt{EM}$  shield member having a contact wall defining 7
- the aperture, the aperture defining contact wall being 8
- in contact with the contact protuberance received in the 9
- aperture. 10

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